IN THE CLAIMS

- 1. 3. (Cancelled)
- 4. (Currently Amended) The apparatus of claim 3,
- A laser apparatus comprising:
 - a Neodymium-doped lasing material,

wherein the lasing material includes a first-surface that is substantially transparent to a pump radiation and substantially reflective to a laser radiation generated by an interaction between the pump radiation and the Neodymium-doped lasing material, and a second surface that transmits at least a portion of the laser radiation; and

wherein the laser radiation is characterized by a vacuum wavelength corresponding to an atomic transition from the 'F_{3/2} level to the 'I_{3/2} level of Neodymium in the lasing material:

a passive O-switch optically coupled to the second surface of the lasing material:

wherein the lasing material and the O-switch are configured to produce pulses of the laser radiation:

wherein the lasing material is Nd:YVO:

wherein the pulses are characterized by a pulse length of greater than zero and less than about 1.5 nanoseconds and a pulse repetition rate greater than about 100 kHz; and

wherein the Neodymium concentration in the lasing material is greater than about 1% and less than

about 3%.

- 5. (Original) The apparatus of claim 4 wherein the Neodymium concentration in the lasing material is about 2%.
- 6. (Currently Amended) The apparatus of claim [[3]] $\underline{4}$ wherein the lasing material is between about 50 microns thick and about 100 microns thick.
- 7. (Currently Amended) The apparatus of claim [[3]] $\underline{4}$ wherein the first surface of the lasing material is configured to transmit between about 0.5% and about 2% of the laser radiation incident upon it from within the lasing material.
- 8. (Original) The apparatus of claim 7 wherein the first surface of the lasing material is configured to transmit about 1% of the laser radiation incident upon it from within the lasing material.
- 9. (Original) The apparatus of claim 8 wherein the first surface is configured to transmit about 0.94% of laser radiation of the ordinary polarization and about 0.98% of laser radiation of the extraordinary polarization.
- 10, 21. (Cancelled)
- 22. (Previously Presented) A laser apparatus comprising:
- a Neodymium-doped lasing material, wherein the lasing material includes a first-surface that is substantially transparent to a pump radiation and substantially reflective to laser radiation generated by an interaction between the pump radiation and the Neodymium-doped lasing material, wherein the laser radiation is characterized by a vacuum wavelength corresponding to an atomic

transition from the $^4F_{3/2}$ level to the $^4I_{9/2}$ level of Neodymium in the lasing material, the lasing material further having a second surface that transmits at least a portion of the laser radiation; and

a passive Q-switch optically coupled to the second surface of the lasing material; and

wherein the lasing material and the Q-switch are configured to produce pulses of the laser radiation;

wherein the pulses are characterized by a pulse length of greater than zero and less than about 1.5 nanoseconds and a pulse repetition rate greater than about 100 kHz;

wherein the Q-switch includes a saturable Bragg reflector (SBR);

wherein the SBR includes a substrate, semiconductor mirror stack having alternating high and low refractive index layers, a quantum well stack having between about 3 and about 15 quantum wells, and a dielectric overcoat;

wherein the semiconductor mirror stack is disposed between the substrate and the quantum wells;

wherein the quantum well stack is disposed between the semiconductor mirror stack and the dielectric overcoat;

wherein the dielectric overcoat includes alternating layers of SiO_2 and HfO_2 ; and

wherein the dielectric overcoat has a reflectivity of between about 87% and about 96% at the wavelength of the laser radiation from the Neodymium-doped lasing material.

23. (Original) The apparatus of claim 22 wherein the dielectric overcoat has a reflectivity of greater than about 90% at the wavelength of the pump radiation.

24. - 31. (Cancelled)

32. (Currently Amended) The PQSL of claim 31,

A passively Q-switched laser (PQSL), comprising:

a source of pump radiation;

a Neodymium-doped lasing material, wherein the lasing material includes a first-surface that is substantially transparent to the pump radiation and substantially reflective to laser radiation characterized by an electronic transition from the $^4F_{3/2}$ level to the $^4I_{9/2}$ level of Neodymium in the lasing material, the lasing material further having a second surface that transmits at least a portion of the laser radiation; and

a passive Q-switch optically coupled to the second surface of the lasing material;

wherein the source of pump radiation, lasing material and Q-switch are configured to produce pulses of laser radiation characterized by a wavelength corresponding to an electronic transition from the 4F_{3/2} level to the 4I_{9/2} level;

wherein the pulses are characterized by a pulse length of greater than zero and less than about 1.5 nanoseconds and a pulse repetition rate greater than about 100 kHz;

wherein the lasing material is Nd:YVO4; and

wherein the Neodymium concentration in the lasing material is greater than about 1% and less than about 3%.

- 33. (Original) The PQSL of claim 32 wherein the Neodymium concentration in the lasing material is about 2%.
- 34. (Currently Amended) The PQSL of claim [[31]] $\underline{32}$ wherein the lasing material is between about 50 microns thick and about 100 microns thick.

- 35. (Currently Amended) The PQSL of claim [[31]] 32 wherein the first surface of the lasing material is configured to transmit between about 0.5% and about 2% of the laser radiation incident upon it from within the lasing material.
- 36. (Original) The PQSL of claim 35 wherein the first surface of the lasing material is configured to transmit about 1% of the laser radiation incident upon it from within the lasing material.
- 37. (Original) The PQSL of claim 36 wherein the first surface is configured to transmit about 0.94% of laser radiation of the ordinary polarization and about 0.98% of laser radiation of the extraordinary polarization.
- 38. 42. (Cancelled)
- 43. (Currently Amended) The apparatus of claim 12,

An apparatus for producing blue light comprising:

a neodymium-doped cladding-pumped fiber device for amplifying laser radiation;

an optical harmonic generator optically coupled to the fiber device for increasing a frequency of the laser radiation to produce a blue output radiation; and

a passively Q-switched laser (PQSL) optically coupled to the neodymium-doped cladding-pumped fiber device, wherein the PQSL is configured to produce the laser radiation, the laser radiation having a harmonic that is blue, whereby the harmonic generator interacts with the laser radiation to produce blue light,

wherein the POSL includes:

In re Patent Application of: KANE ET AL

Serial No. 10/662,086 Filed: 09/12/03

a source of pump radiation;

a Neodymium-doped lasing material, wherein the lasing material includes a first-surface that is substantially transparent to the pump radiation and substantially reflective to laser radiation characterized by a by an electronic transition from the $^4F_{3/2}$ level to the $^4I_{9/2}$ level of Neodymium in the lasing material, the lasing material further having a second surface that transmits at least a portion of the laser radiation; and

a passive Q-switch optically coupled to the second surface of the lasing material;

wherein the source of pump radiation, lasing material and Q-switch are configured to produce pulses of the laser radiation characterized by a wavelength corresponding to an electronic transition from the ⁴F_{3/2} level to the ⁴I_{9/3} level;

wherein the pulses are characterized by a pulse length of greater than zero and less than about 1.5 nanoseconds and a pulse repetition rate greater than about 100 kHz;

wherein the lasing material is Nd:YVO4; and

wherein the Neodymium concentration in the lasing material is greater than about 1% and less than about 3%.

- 44. (Original) The apparatus of claim 43 wherein the Neodymium concentration in the lasing material is about 2%.
- 45. (Currently Amended) The apparatus of claim [[42]] 43 wherein the lasing material is between about 50 microns thick and about 100 microns thick.
- 46. (Currently Amended) The apparatus of claim [[42]] 43 wherein the first surface of the lasing material is configured to

transmit between about 0.5% and about 2% of the laser radiation incident upon it from within the lasing material.

- 47. (Original) The apparatus of claim 46 wherein the first surface of the lasing material is configured to transmit about 1% of the laser radiation incident upon it from within the lasing material.
- 48. (Original) The apparatus of claim 47 wherein the first surface is configured to transmit about 0.94% of laser radiation of the ordinary polarization and about 0.98% of laser radiation of the extraordinary polarization.
- 49. 55. (Cancelled)